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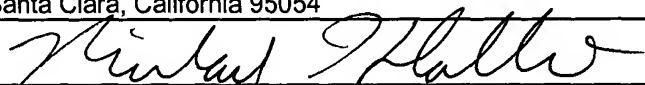
		Application Number	10/634,568
		Filing Date	August 4, 2003
		First Named Inventor	Jaime Poris
		Group Art Unit	2877
		Examiner Name	Michael A. Lyons
Total Number Of Pages In This Submission	4 pages + 7 Refs.	Attorney Docket No.	NAN042-1D US

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Remarks

SIGNATURE OF APPLICANT, ATTORNEY OR AGENT

Firm or Individual Name	Michael J. Halbert (Reg. No. 40,633) Silicon Valley Patent Group LLP 2350 Mission College Boulevard, Suite 360 Santa Clara, California 95054
Signature	
Date	9-8-03

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Inventors: Jaime Poris; Claudio L. Rampoldi
Assignee: Nanometrics Incorporated
Title: Profiling Method
Serial No.: 10/634,568 Filing Date: August 4, 2003
Examiner: Michael A. Lyons Group Art Unit: 2877
Docket No.: NAN042-1D US Confirmation No: Unknown

Santa Clara, California
September 8, 2003

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**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §1.97(b)**

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, §1.97 and §1.98, the Applicants submit for consideration in the above-identified patent application the document listed on the accompanying Form PTO-1449. A copy of the document is also submitted herewith. The Examiner is requested to make this document of record.

This Information Disclosure Statement is submitted pursuant to 37 CFR §1.97(b) as it within three months of the filing date of a national application other than a continued prosecution application and/or before the mailing of a first Office Action on the merits. Accordingly, no fee is required.

Applicants would appreciate the Examiner initialing and returning the Form PTO-1449, indicating that the information has been considered and made of record herein.

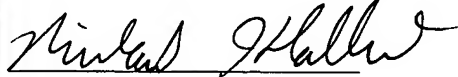
The information contained in this Information Disclosure Statement under 37 C.F.R. §1.555 is to the best of my knowledge and is not to be construed as a representation that: (i) a complete search has been made; (ii) additional information material to the

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examination of this application does not exist; (iii) the information, protocols, results and the like reported by third parties are accurate or enabling; or (iv) the above information constitutes prior art to the subject invention.

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Respectfully submitted,



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					Filing Date:		August 8, 2003	
					First Named Inventor:		Jaime Poris	
					Group Art Unit:		Unknown	
					Examiner Name:		Unkonwn	
					Confirmation No.:		Unkonwn	
					Attorney Docket No.:		NAN042-1D US	
U.S. Patent Documents								
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate		
	26.	6,568,290	May 27, 2003	Poris	73	866		
	27.	2002/0174714A1	Nov. 28, 2002	McWaid et al.	73	105		
	28.	6,194,317	Feb 27, 2001	Kaisaki et al.	438	692		
	29.	4,512,661	Apr. 23, 1985	Claus et al.	356	351		
	30.	5,604,591	Feb. 18, 1997	Kitagawa	356	351		
Foreign Patent Documents								
							Translation	
	Document	Date	Country	Class	Subclass	Yes	No	
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
	31.	Malacara, Daniel et al. "Interferogram Analysis For Optical Testing" 1998, Marcel Dekker, Inc. pp. 113						
	32.	Stine, B. et al., "Rapid Characterization and Modeling of Pattern-Dependent Variation in Chemical-Mechanical Polishing", IEEE Transactions on Semiconductor Manufacturing, Vol. 11, No. 1, pp. 129-140 (Feb. 1998)						
Examiner		Date Considered						
*EXAMINER: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.								